

Notice of References Cited	Application/Control No. 10/574,030	Applicant(s)/Patent Under Reexamination VAN SCHAIJK ET AL.	
	Examiner HSIN-YI HSIEH	Art Unit 2811	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0065917 A1	04-2004	Fan et al.	257/315
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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